Appl. No. <u>10/077,072</u> Appl. dated <u>11/7/2003</u>

Replice Office action of 09/09/2003

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:)	
••)	Group Art Unit: 2821
FISCHER et al.)	-
)	Examiner: LEE, Wilson
Application No: 10/077,072)	
)	Atty. Docket No: P0877
Filed: February 14, 2002)	
)	Date: November 7, 2003
For: A PLASMA PROCESSING APPARATUS)	
AND METHOD FOR CONFINING AN RF)	
PLASMA UNDER VERY HIGH GAS FLOW)	
AND RF POWER DENSITY CONDITIONS	_)	

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 7, 2003.

Signed: Sharon Tillery

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT

Dear Sir:

In response to the Office Action mailed on September 9, 2003, please enter the following amendments and remarks in the above-identified patent application:

Amendments to the specifications begin on page 2.

Amendments to the claims are reflected in the listing of claims, which begins on page 3 of this paper.

Remarks/Arguments begin on page 8 of this paper.